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Here, However, It Reduces The Etch Rate. The Effect Of Flow Limited Etching Is Apparent For Both Etch Step Time Settings At Low Flow. The Highest Etch Rates Are Obtained For Oxygen Flows Of 100 Sccm In RIE Mode Which Corresponds To The Maximum Flow Rate Limit Of The Etching Figure 3: Etch Rates Of Parylene And AZ 4620 For Varying Feb 1th, 2024

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